

Diffusing wave spectroscopy in elastomer fracture

Jianzhu Ju

Supervisors: Costantino Creton, Tetsuharu Narita

In collaboration with Luca Cipelletti (Montpellier, CNRS)



Fracture at different length scale

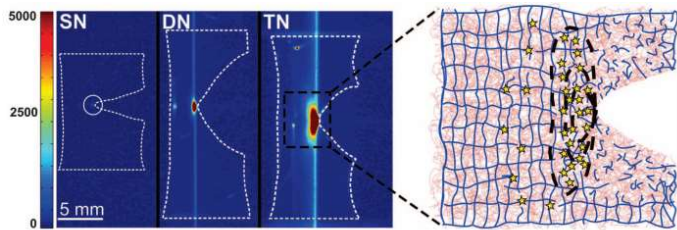
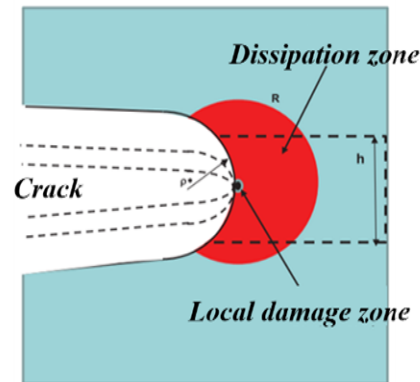


Fig. 5. Mapping of where bonds break during crack propagation. Intensity-colored images of propagating cracks on notched samples containing dioxetane cross-linker in the first network, showing the light emission due to the breakage of bonds in SN, DN, and TN samples. The size and geometry of the sample are shown with a white dashed line. Vertical lines in the DN and TN image are due to detector artifacts; in DN and TN, spots far from the crack tip are due to reflection of the light on surface inhomogeneities and do not correspond to a local light emission. (Right) Schematic of the sacrificial bond-breaking mechanism in front of the crack tip for the DN and TN; the first network is represented in blue, and the second and third networks are in red.



Molecular scale
(~10nm)

Ducrot, Etienne, et al.2014

Mesoscopic scale
(0.1 ~10 μ m)

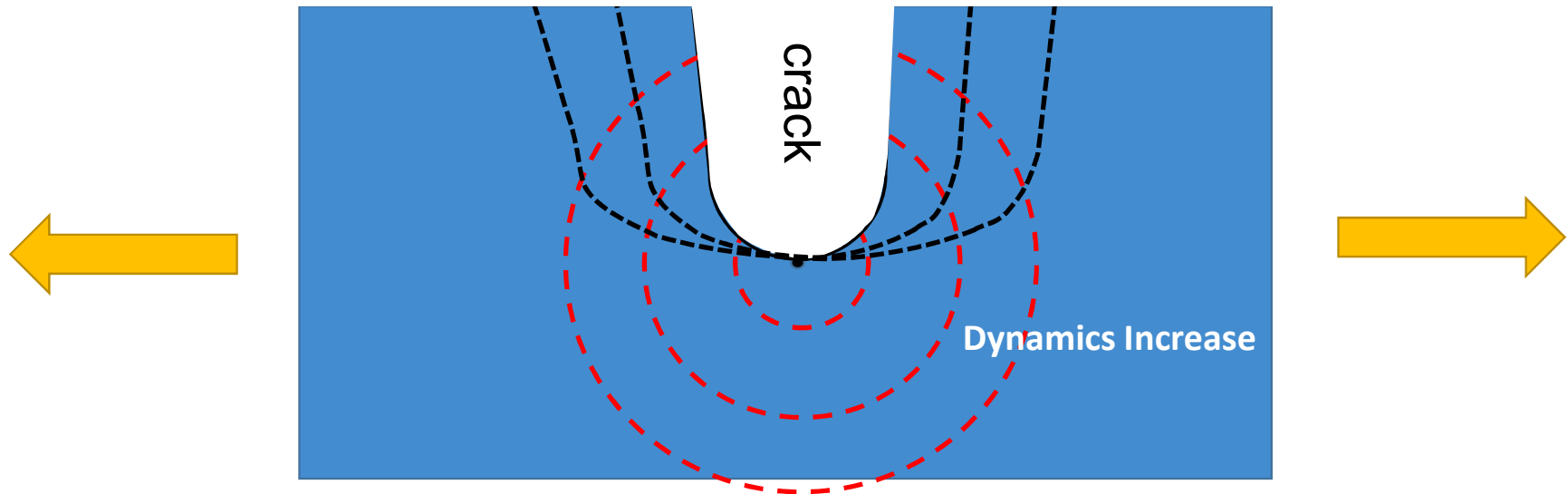
Creton, Costantino, and Matteo Ciccotti.2016

Macroscopic scale

Martínez, A. B., et al. 2017

Open question: How the network is damaged in mesoscopic scale?

Fracture precursor



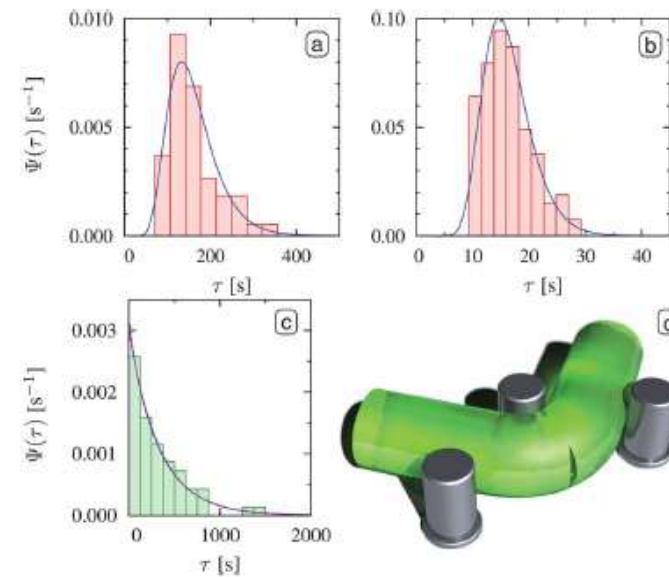
Fracture prediction?

Characterization methods?

Delayed fracture

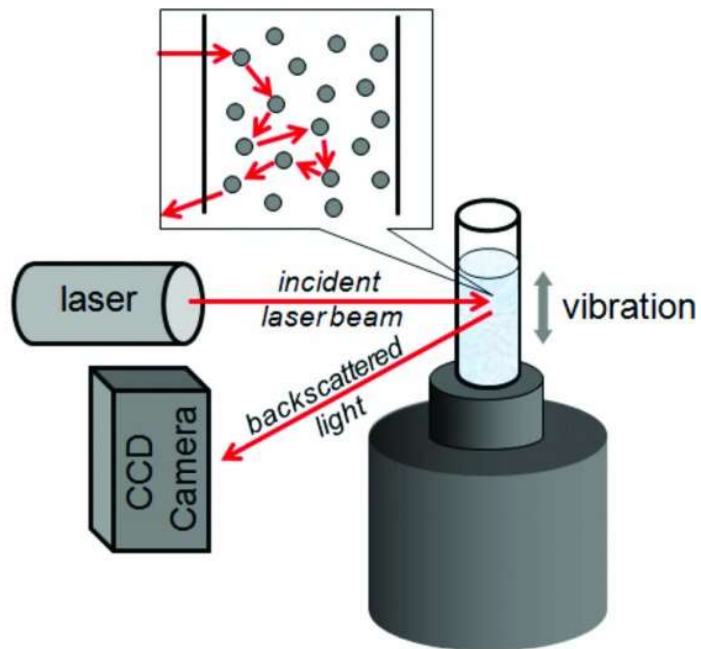


Bonn, Daniel, et al. "Delayed fracture of an inhomogeneous soft solid." *Science* 280.5361 (1998): 265-267.

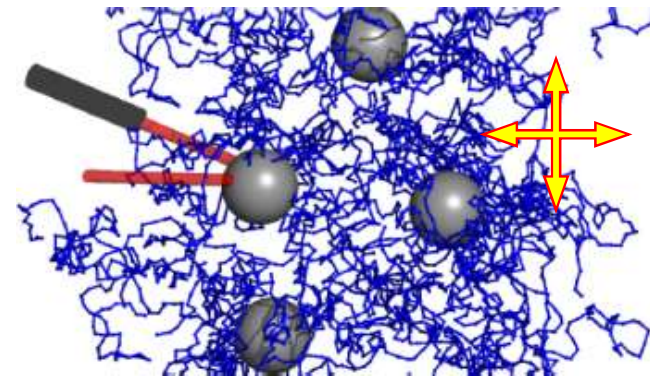


Lindström, Stefan B., et al. "Structures, stresses, and fluctuations in the delayed failure of colloidal gels." *Soft Matter* 8.13 (2012): 3657-3664.

DWS technology in polymer network



Methods:
diffusing wave spectroscopy (DWS)



Measure requirement:
Polymer network + Probe particles

Krajina, Brad A., et al. 2017

Application of DWS technology on polymer network

- **1. Sample preparation**

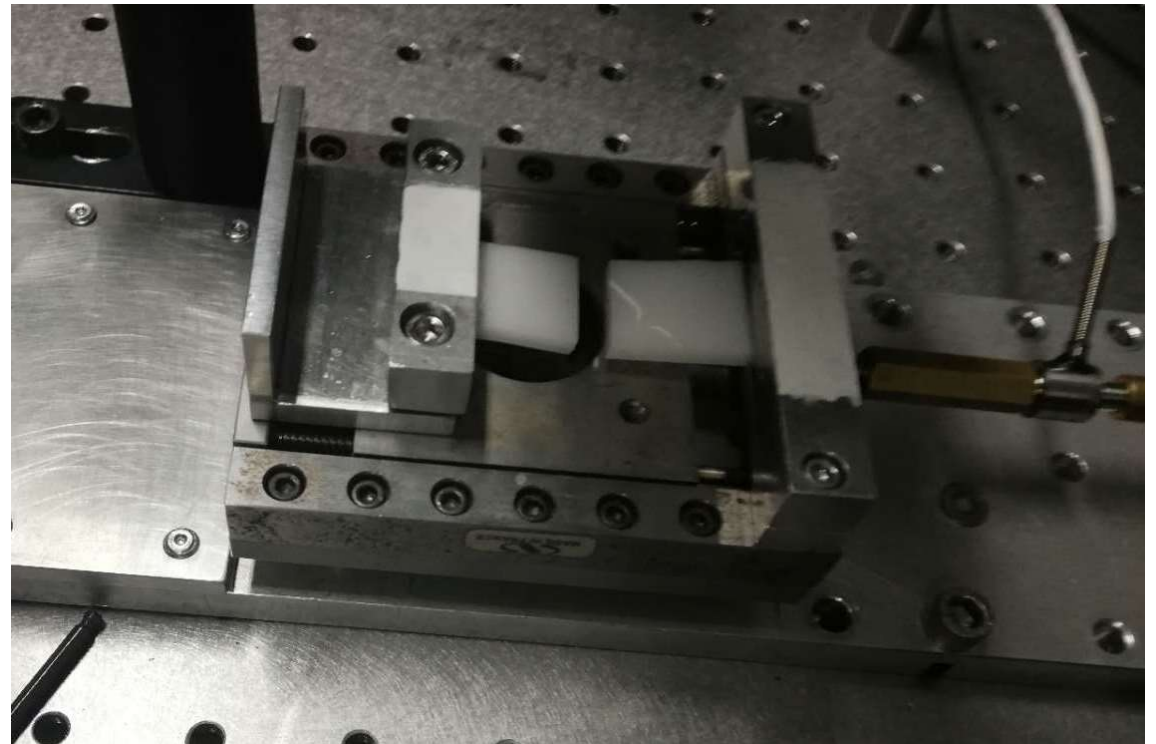
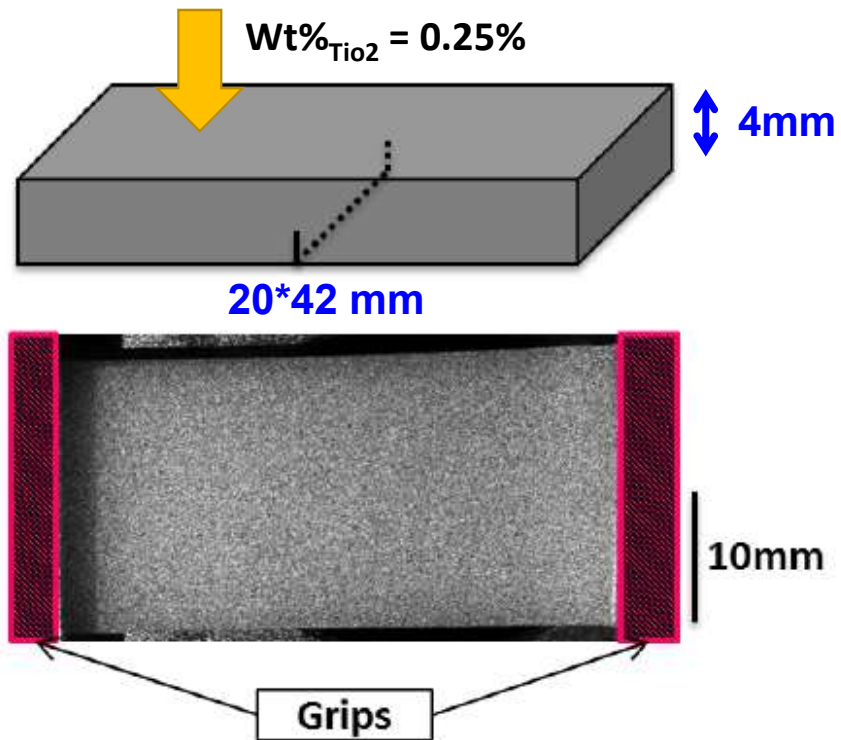
Introduction probe particles during crosslinking

- 1. PDMS (model sample)
- 2. Multiple networks from acrylates (from Laboratory)
- 3. Double Dynamic networks (from other partners)

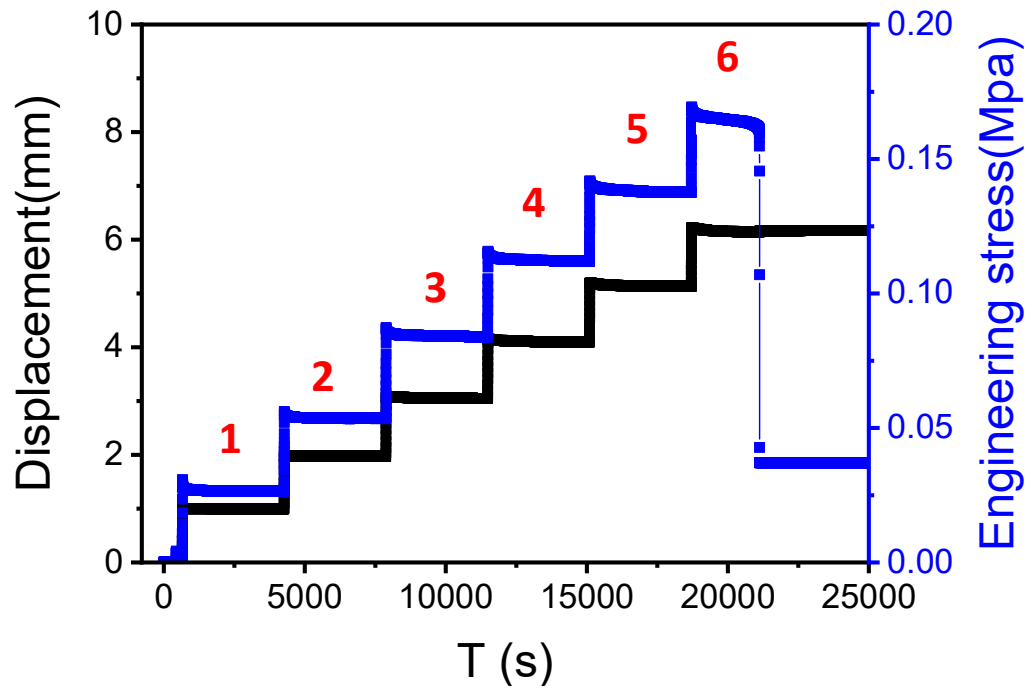
- **2. Set-up development**

- 1. optical part (DWS testing system)
- 2. mechanical part (Tensile machine)

Preliminary results: fracture precursor in PDMS

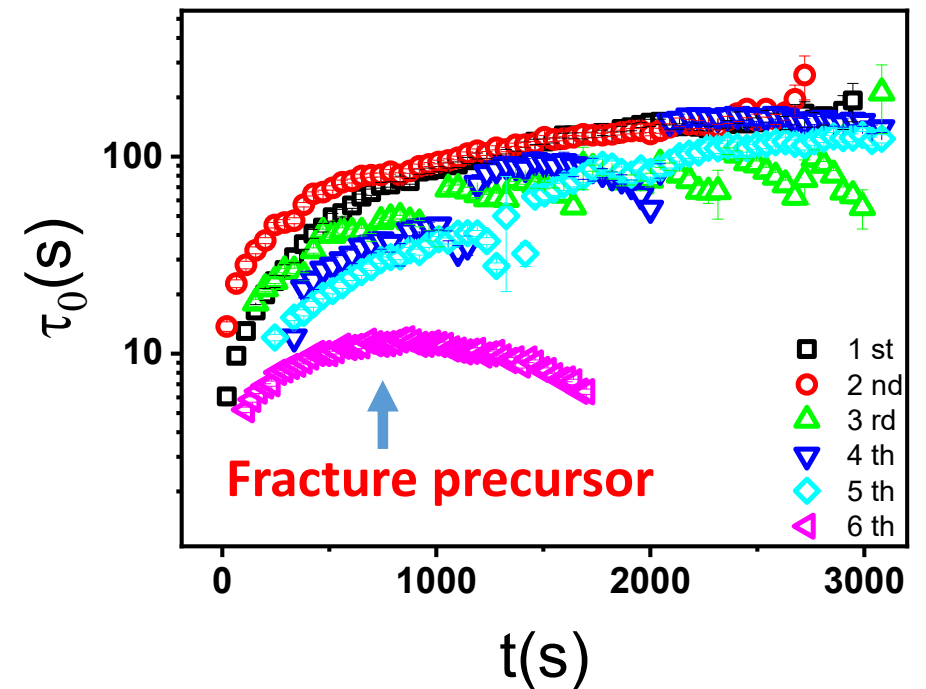


Fracture precursor

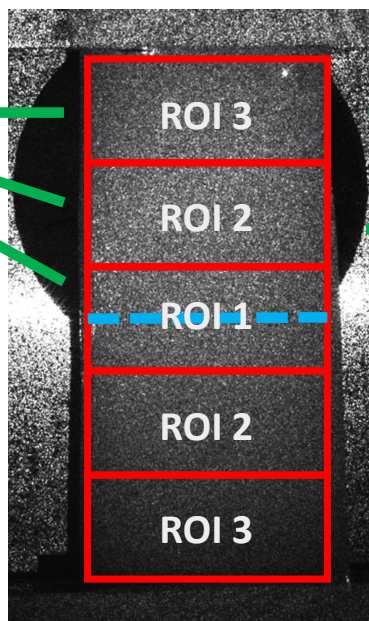
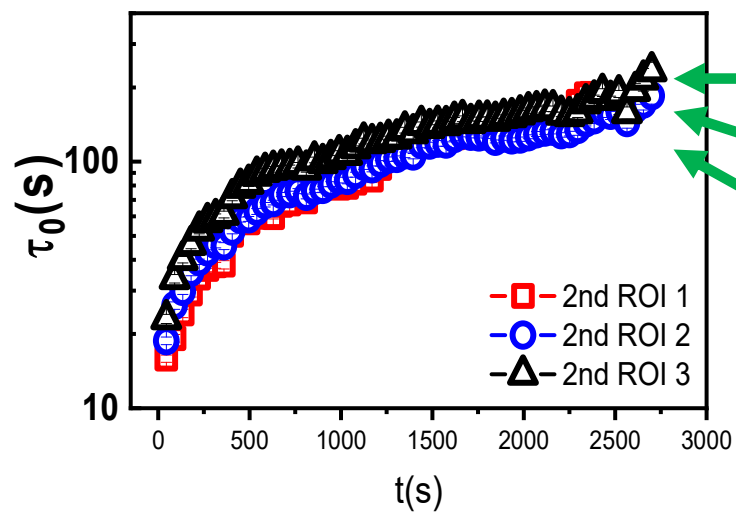


$$g_2(\tau)-1 = \frac{\langle I_P(t)I_P(t+\tau) \rangle_P}{\langle I_P(t) \rangle_P \langle I_P(t+\tau) \rangle_P} - 1$$

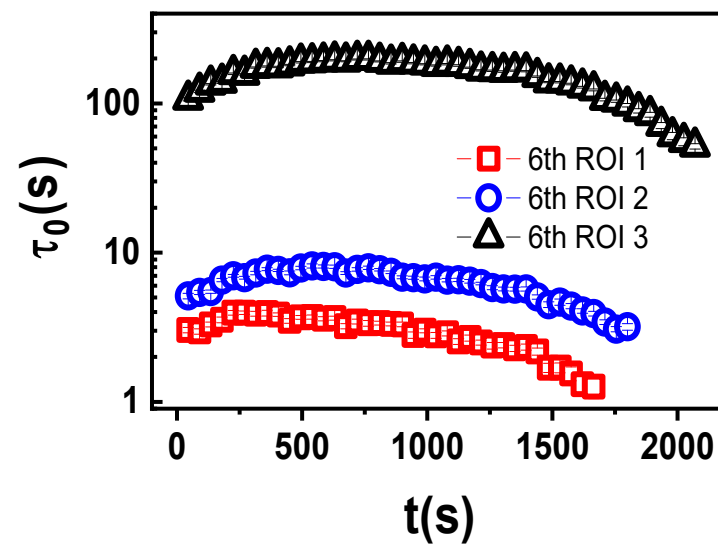
$$= A \exp \left(- \left(\frac{\tau}{\tau_0} \right)^P \right) + B$$



2nd



6th



$\tau_0(x, y)$

Application of DWS technology on polymer network

- 1. Sample preparation

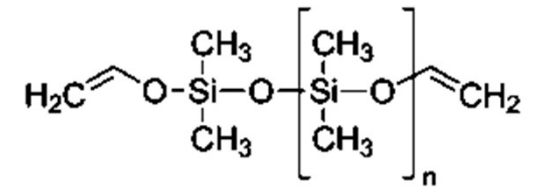
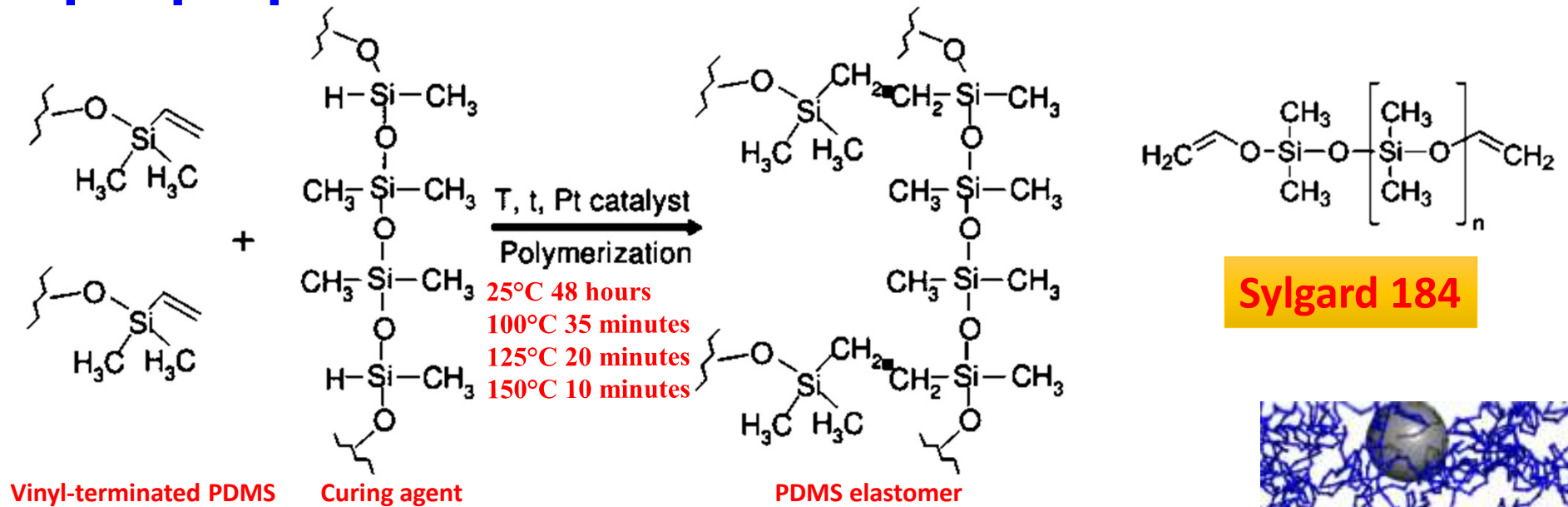
Introduction probe particles during crosslinking

- 1. PDMS (model sample)
- 2. Multiple networks from acrylates (from Labortory)
- 3. Double Dynamic networks (from other partner)

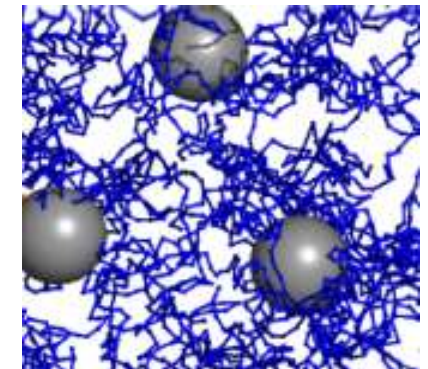
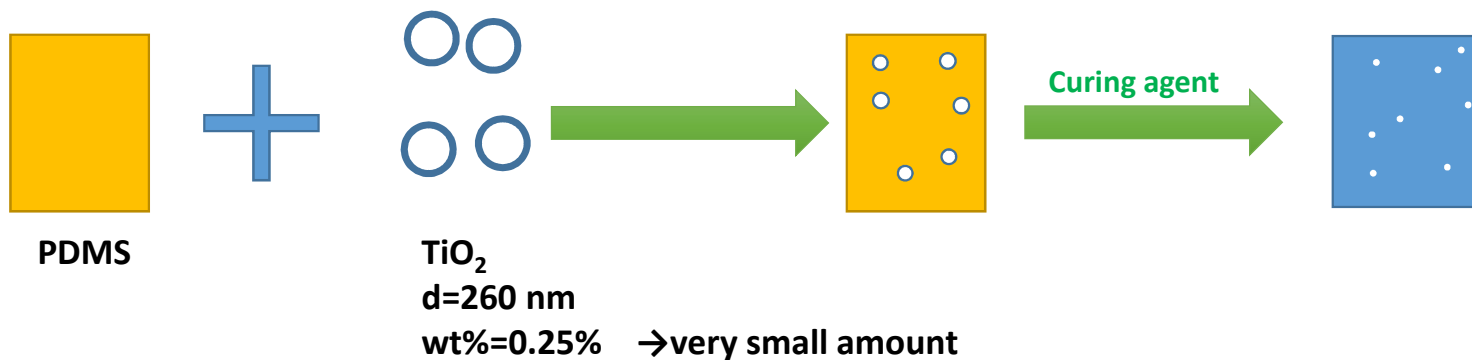
- 2. Set-up development

- 1. optical part (DWS testing system)
- 2. mechanical part (Tensile machine)

Sample preparation

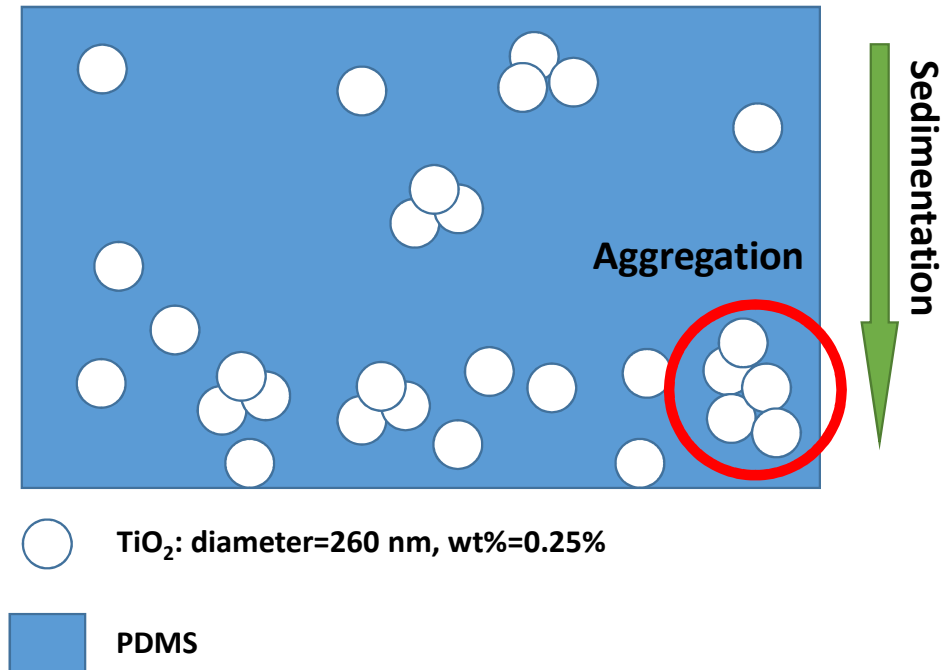


Sylgard 184



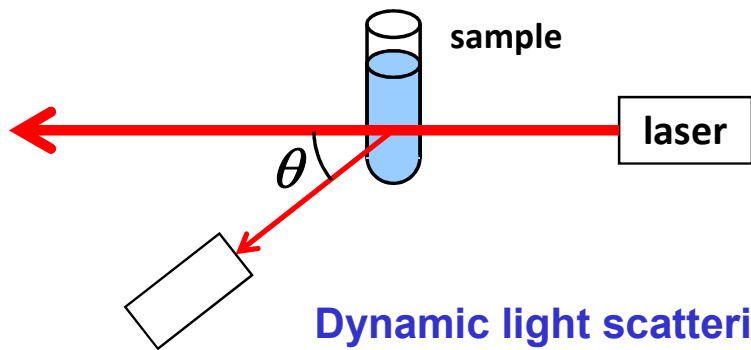
Aggregation and Sedimentation

Elastomer after curing (RT)



1. Aggregation → sonication
2. Sedimentation → heating

Characterization in PDMS base: DLS and DWS

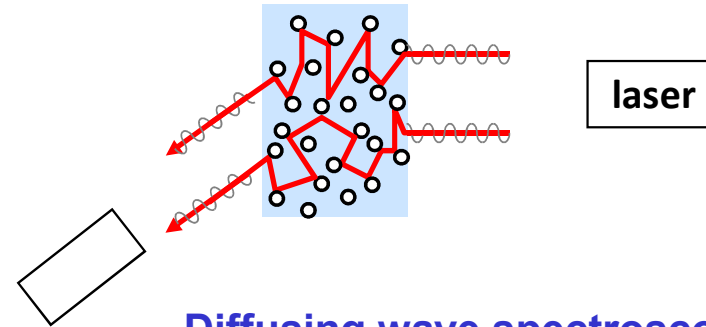


Dynamic light scattering (DLS)

$$g_2(t) = \frac{\langle I(t') \cdot I(t' + t) \rangle}{\langle I(t') \rangle^2}$$

$$= 1 + \beta [g_1(t)]^2$$

$$g_1(q, t) = \exp \left[-\frac{\langle \Delta r^2(t) \rangle \cdot q^2}{6} \right]$$



Diffusing wave spectroscopy (DWS)

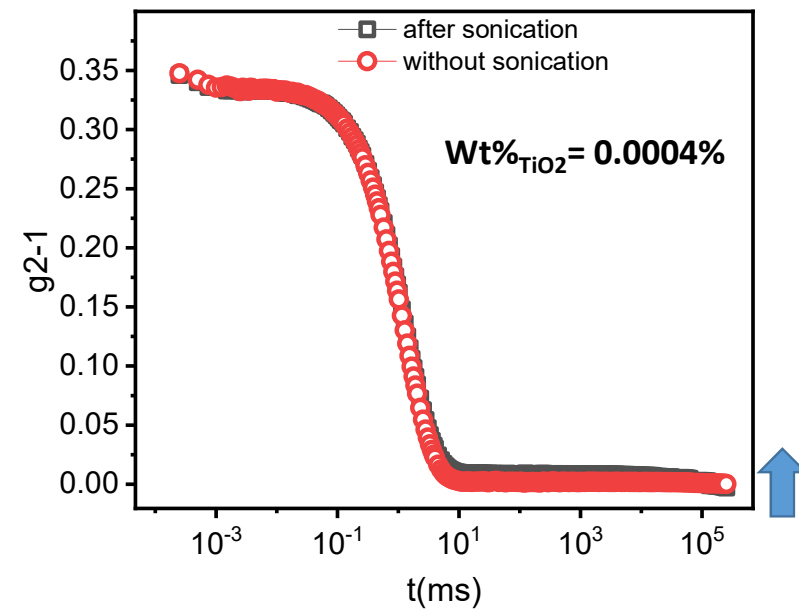
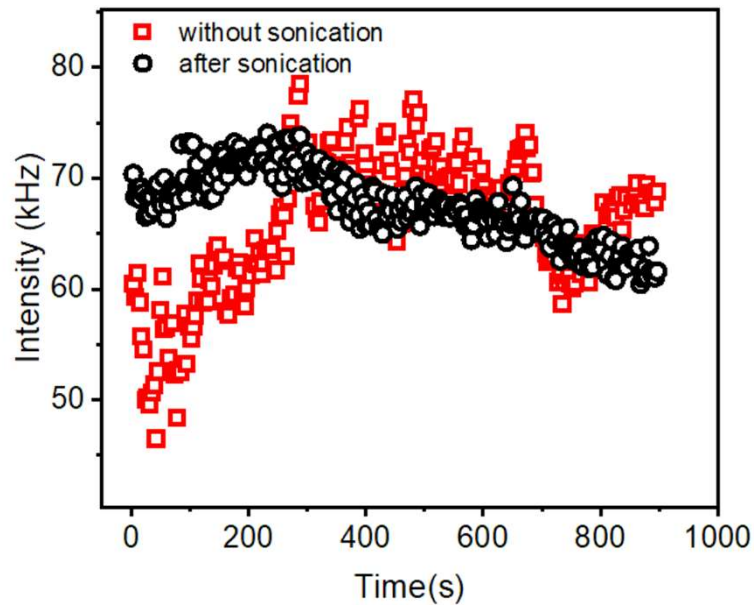
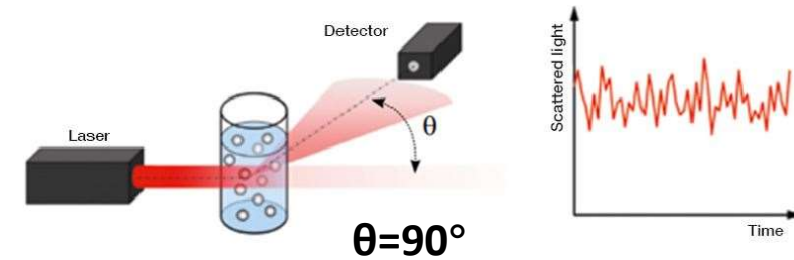
$$g_2(t) = \frac{\langle I(t') \cdot I(t' + t) \rangle}{\langle I(t') \rangle^2}$$

$$= 1 + \beta [g_1(t)]^2$$

$$g_1(t) = \frac{\frac{L/l^* + 4/3}{5/3} \sinh \left(\sqrt{k_0^2 \langle \Delta r^2(t) \rangle} \right) + \frac{2}{3} \sqrt{k_0^2 \langle \Delta r^2(t) \rangle} \cosh \left(\sqrt{k_0^2 \langle \Delta r^2(t) \rangle} \right)}{\left(1 + \frac{4}{9} k_0^2 \langle \Delta r^2(t) \rangle \right) \sinh \left(\frac{L}{l^*} \sqrt{k_0^2 \langle \Delta r^2(t) \rangle} \right) + \frac{4}{3} \sqrt{x} \cosh \left(\frac{L}{l^*} \sqrt{k_0^2 \langle \Delta r^2(t) \rangle} \right)}$$

$\langle r^2 \rangle$: Mean square displacement (MSD)

Size measurement in water (DLS)



$$D_{\text{TiO}_2} = 260 \text{ nm}$$

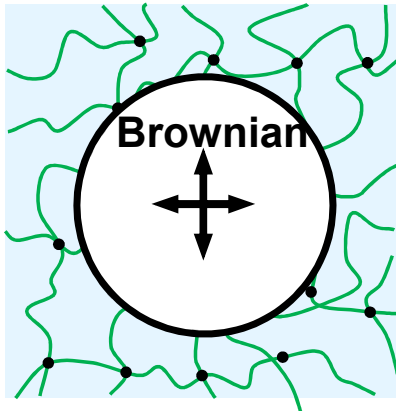
In dilute suspension, aggregation can be observed, but negligible.

Sedimentation in PDMS (time-averaged DWS)

Brownian movement

$$\langle r^2 \rangle = 6Dt = \frac{kT}{\pi r \eta} t$$

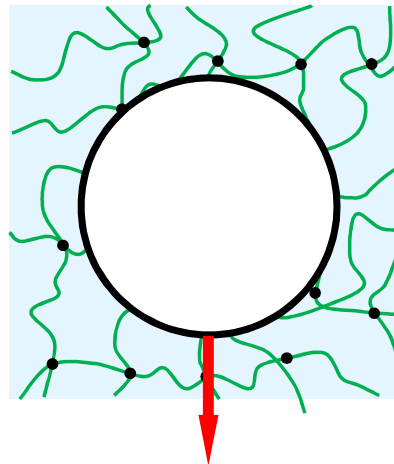
$$\frac{d \ln \langle r^2 \rangle}{d \ln t} = 1$$



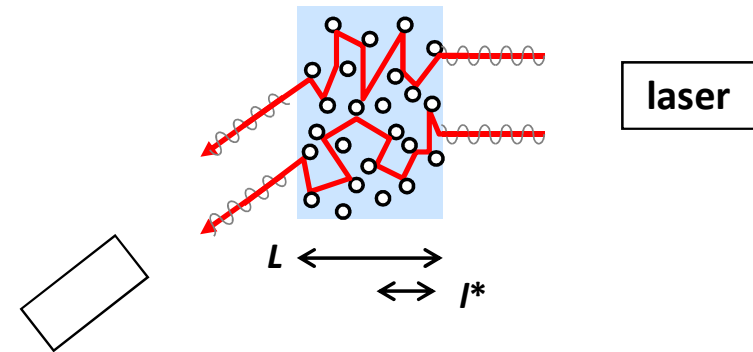
Equilibrium sedimentation velocity v_e

$$\langle r^2 \rangle = (v_e t)^2$$

$$\frac{d \ln \langle r^2 \rangle}{d \ln t} = 2$$



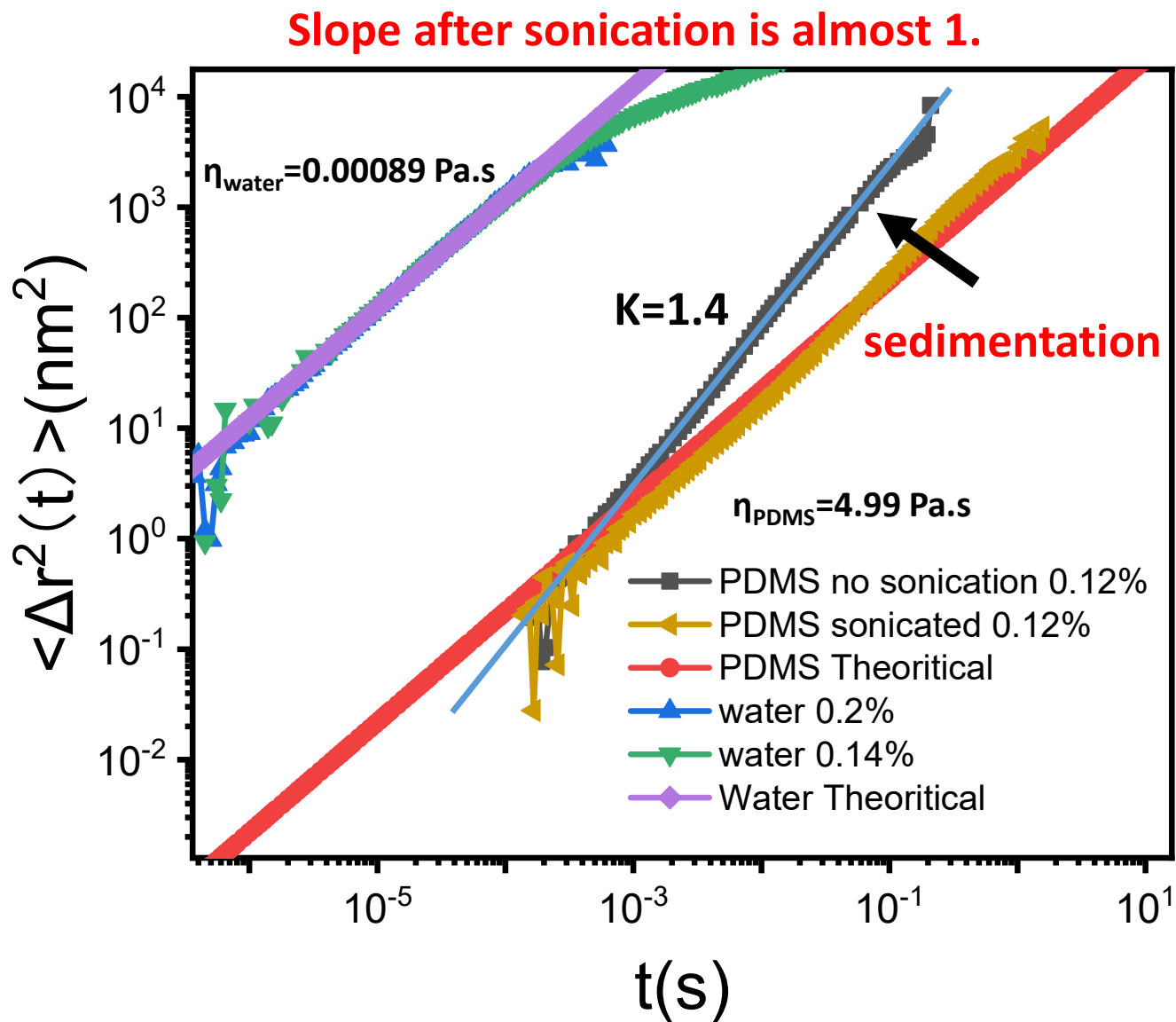
Sedimentation



Theoretical value (only consider Brownian movement) :

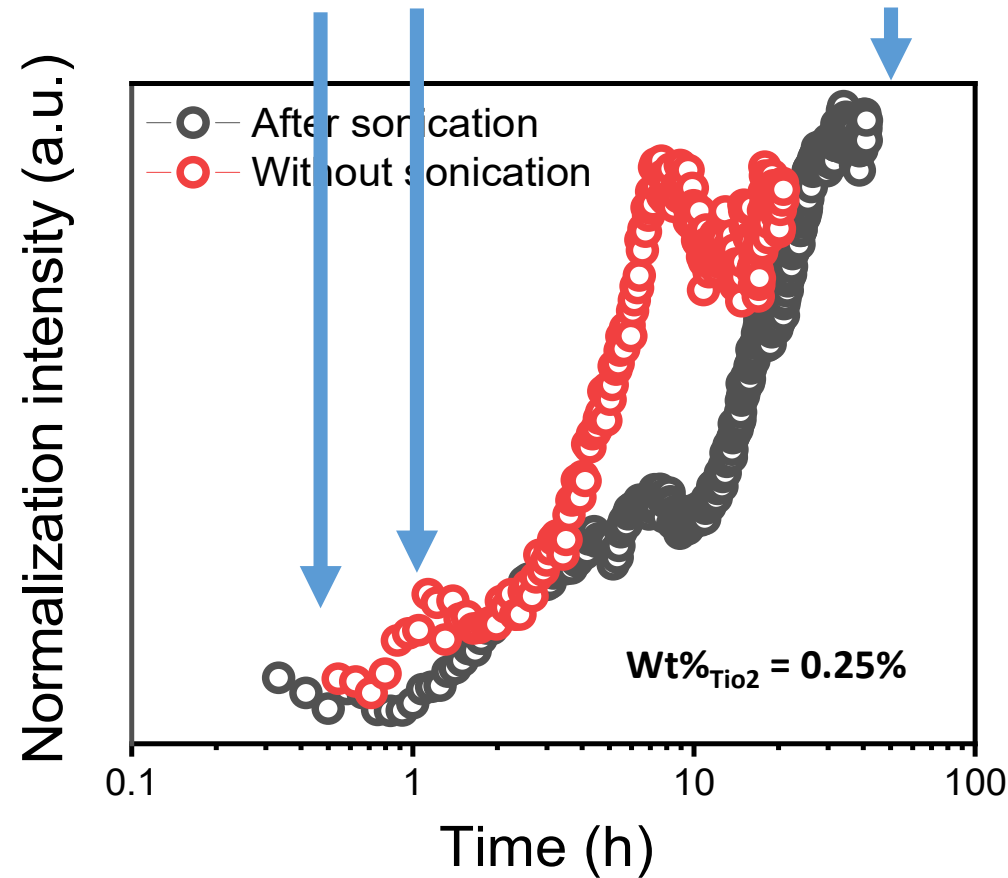
$$\langle r^2 \rangle = 6Dt = \frac{kT}{\pi r \eta} t$$

$$\frac{d \ln \langle r^2 \rangle}{d \ln t} = 1$$



Sedimentation in PDMS (ensemble averaged DWS)

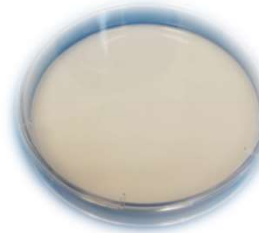
curing temperature: 100 °C 90 °C



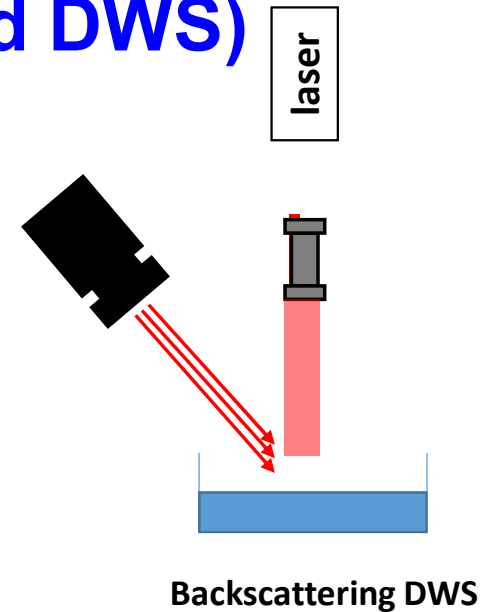
5 Days



No sonication



After sonication



No sonication, cured at room temperature



After sonication, cure at 90 °



Summary

- 1. Sedimentation and aggregation of PDMS are characterized by DWS.**
- 2. Aggregation can be effectively reduced by sonication.**
- 3. Influence of sedimentation can be reduced by curing at higher temperature.**

Application of DWS technology on polymer network

- 1. Sample preparation

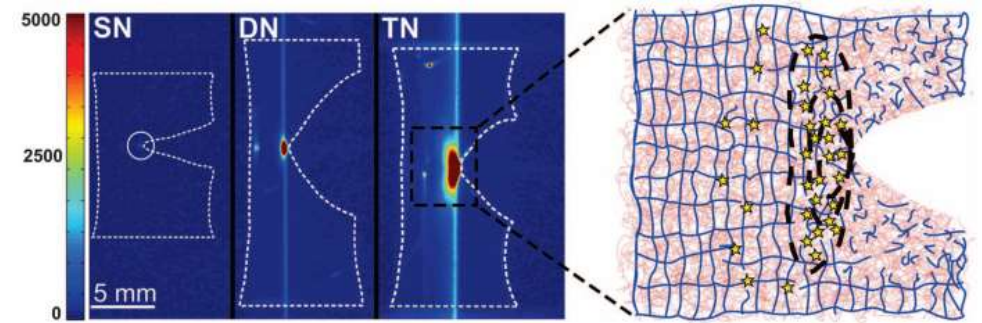
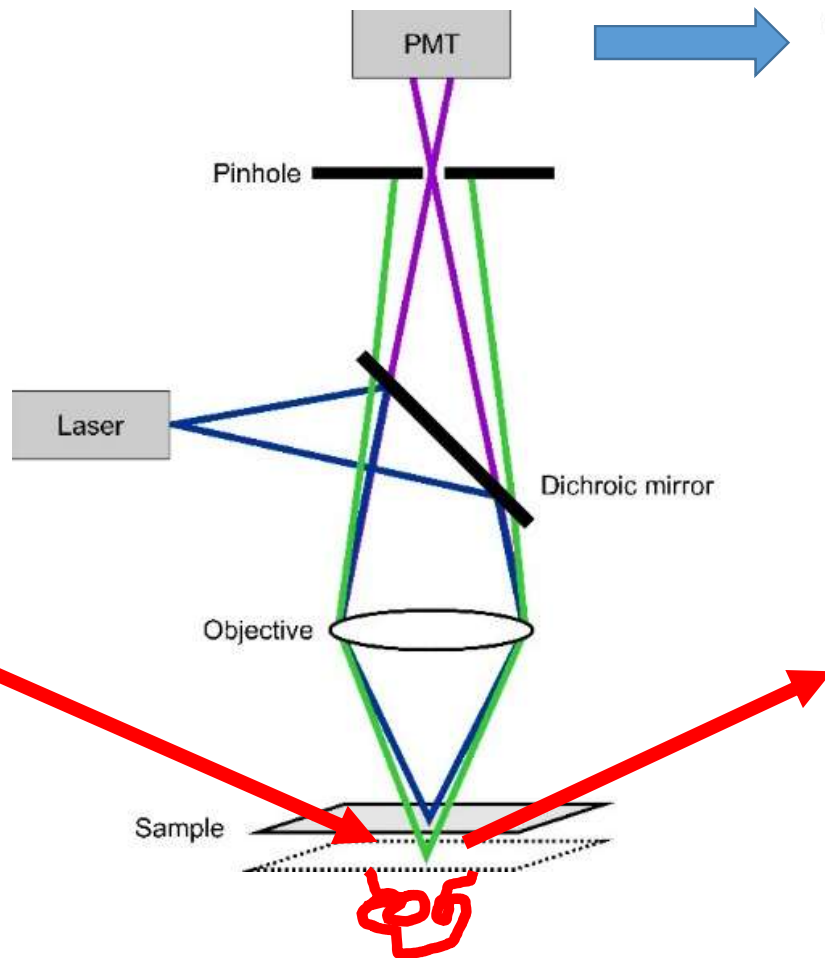
Introduction probe particles during crosslinking

- 1. PDMS (model sample)
- 2. **Multiple networks from acrylates (from Labortory)**
- 3. Double Dynamic networks (from other partner)

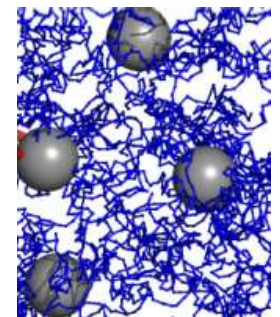
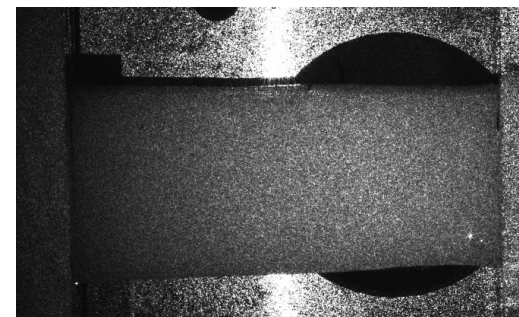
- 2. Set-up development

- 1. optical part (DWS testing system)
- 2. mechanical part (Tensile machine)

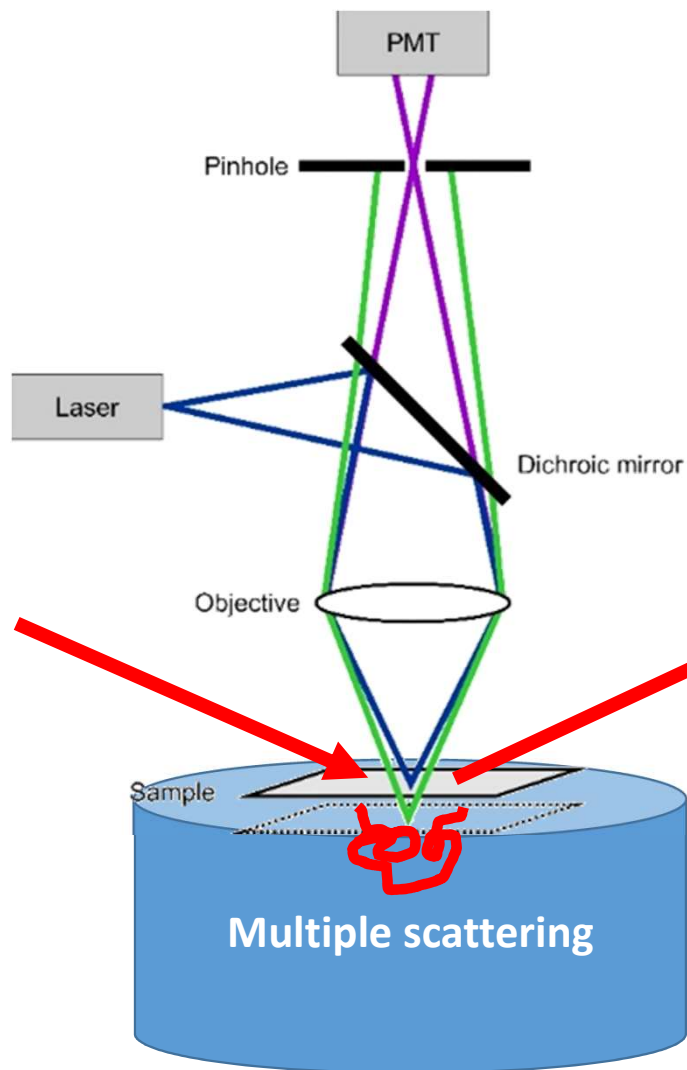
Goal: DWS & confocal microscopy



Molecular scale ($\sim 10\text{nm}$)



Mesoscopic scale ($0,1 \sim 10 \mu\text{m}$)



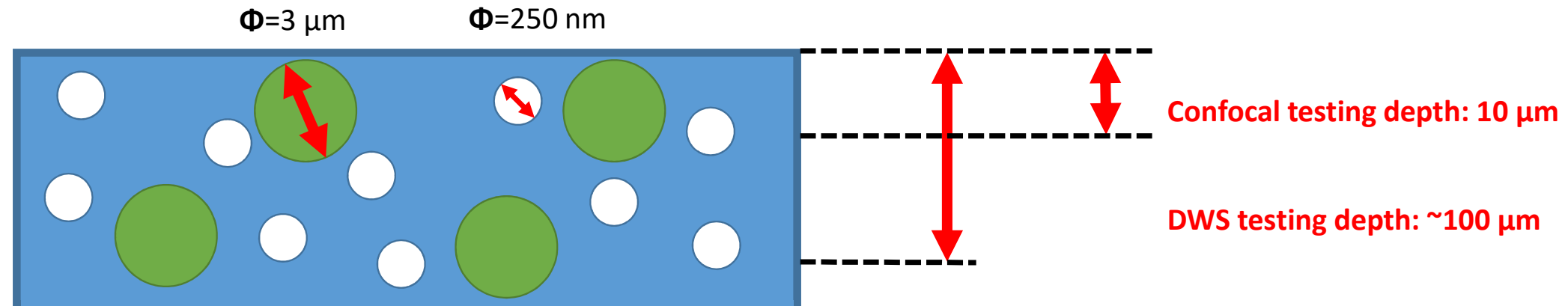
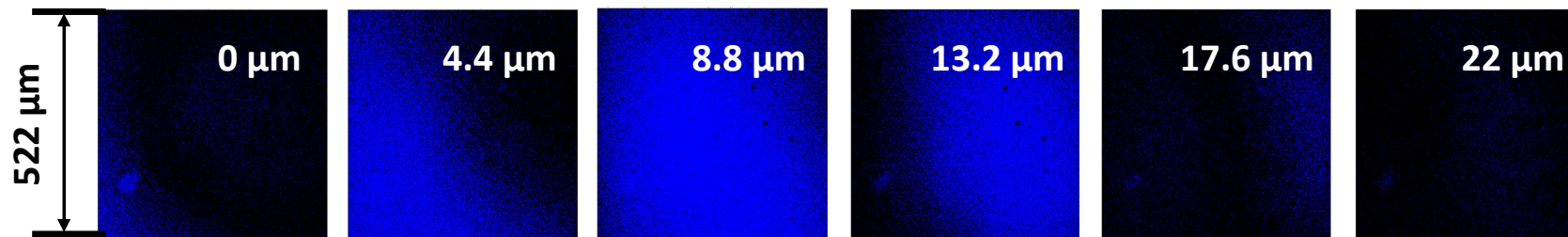
	Material requirement	Depth Limitation
confocal microscopy	Mechanofluorochromic materials	~100 μm
DWS	Probe particles	$I^* \sim 100 \mu\text{m}$

transparent

white

Trade off between multiple scattering and confocal measure depth

Probe particles influence in confocal microscopy (PDMS)



- Fluorescent Si particles: wt%=0.025%, $\Phi=3 \mu\text{m}$
- TiO_2 : wt%=0.06%, $\Phi=250 \text{ nm}$
- PDMS

Application of DWS technology on polymer network

- **1. Sample preparation**

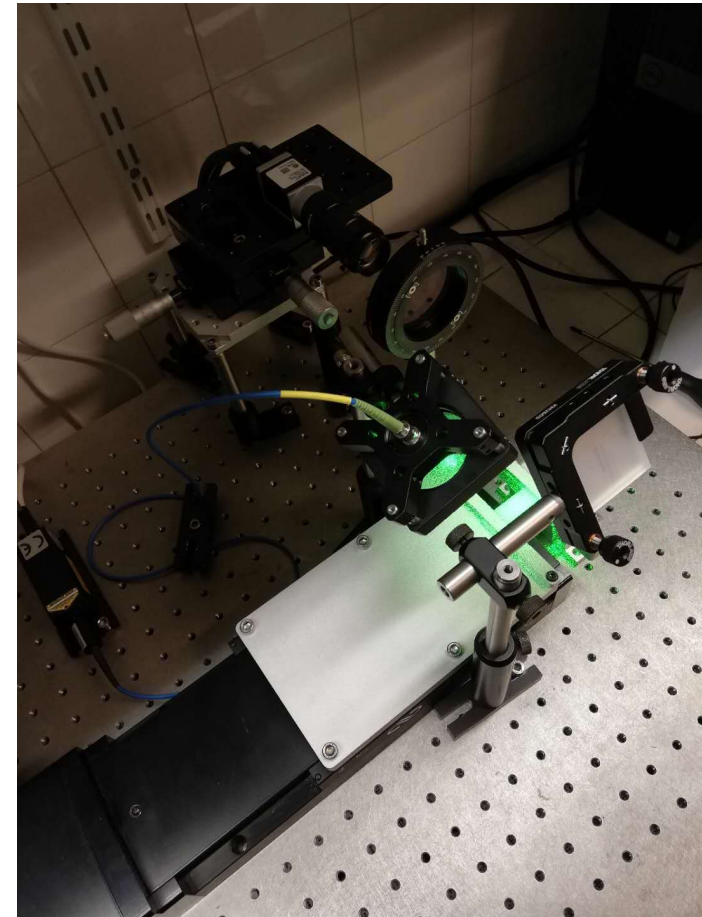
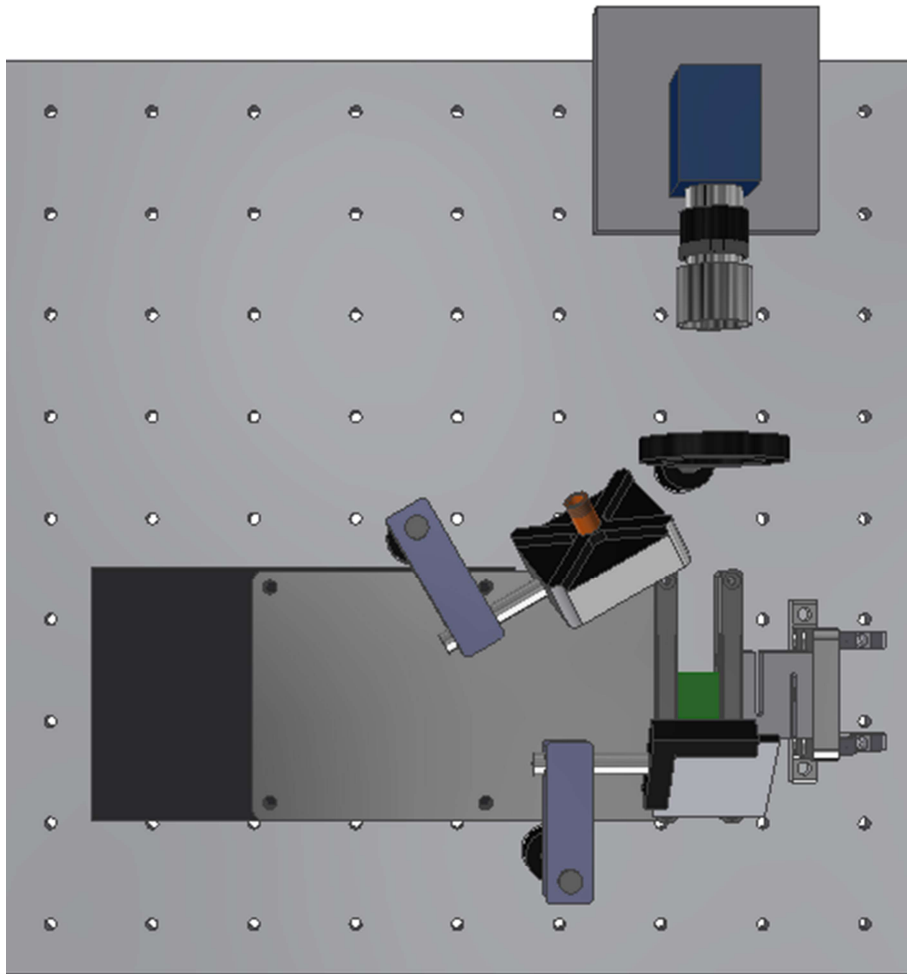
Introduction probe particles during crosslinking

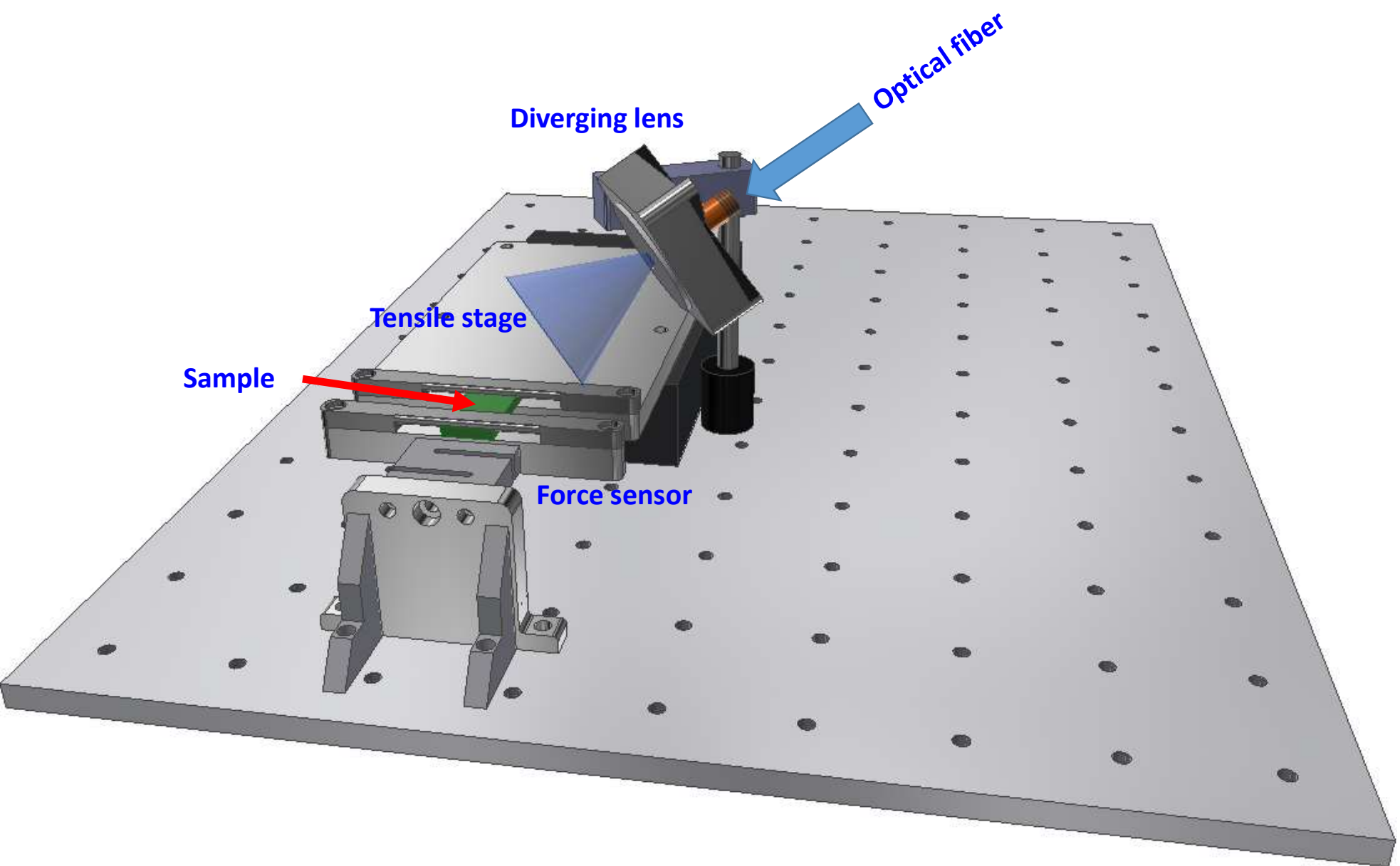
- 1. PDMS (model sample)
- 2. Multiple networks from acrylates (from Labortory)
- 3. Double Dynamic networks (from other partner)

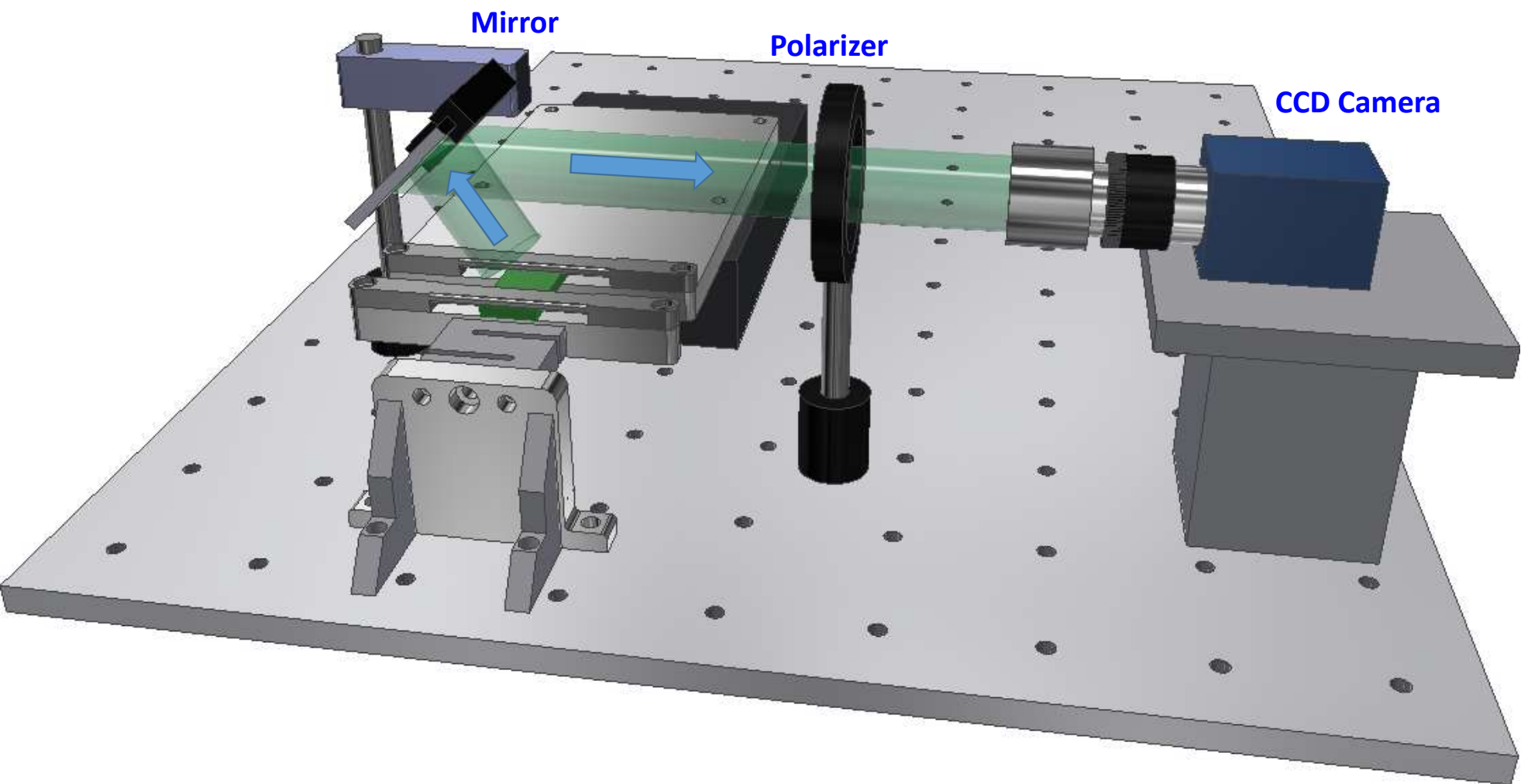
- **2. Set-up development**

- 1. **optical part (DWS testing system)**
- 2. mechanical part (Tensile machine)

Fabrication of DWS testing Set-up in lab







Application of DWS technology on polymer network

- **1. Sample preparation**

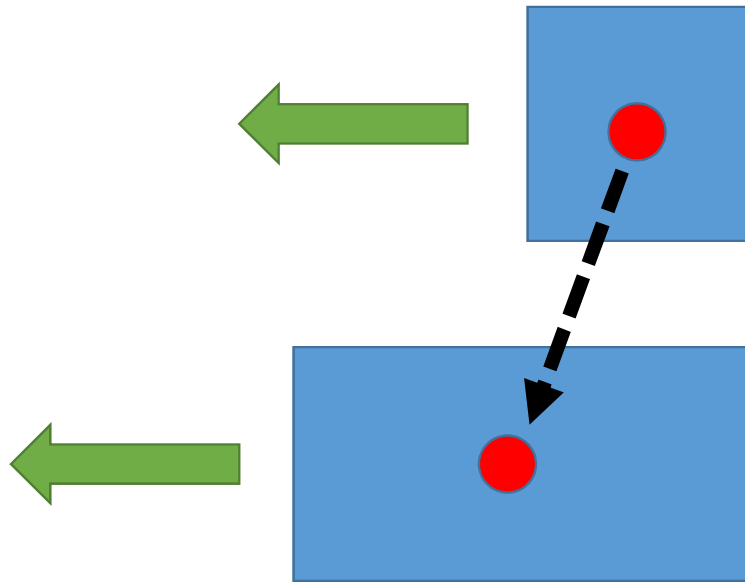
Introduction probe particles during crosslinking

- 1. PDMS (model sample)
- 2. Multiple networks from acrylates (from Laboratory)
- 3. Double Dynamic networks (from other partner)

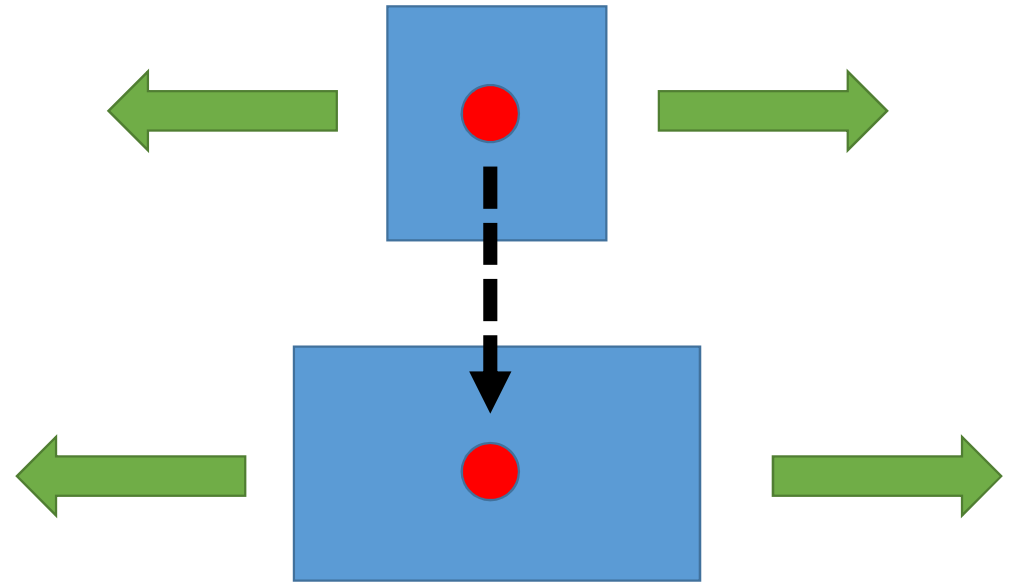
- **2. Set-up development**

- 1. optical part (DWS testing system)
- **2. mechanical part (Tensile machine)**

unidirectional tensile



bidirectional tensile



Combination of different measurement



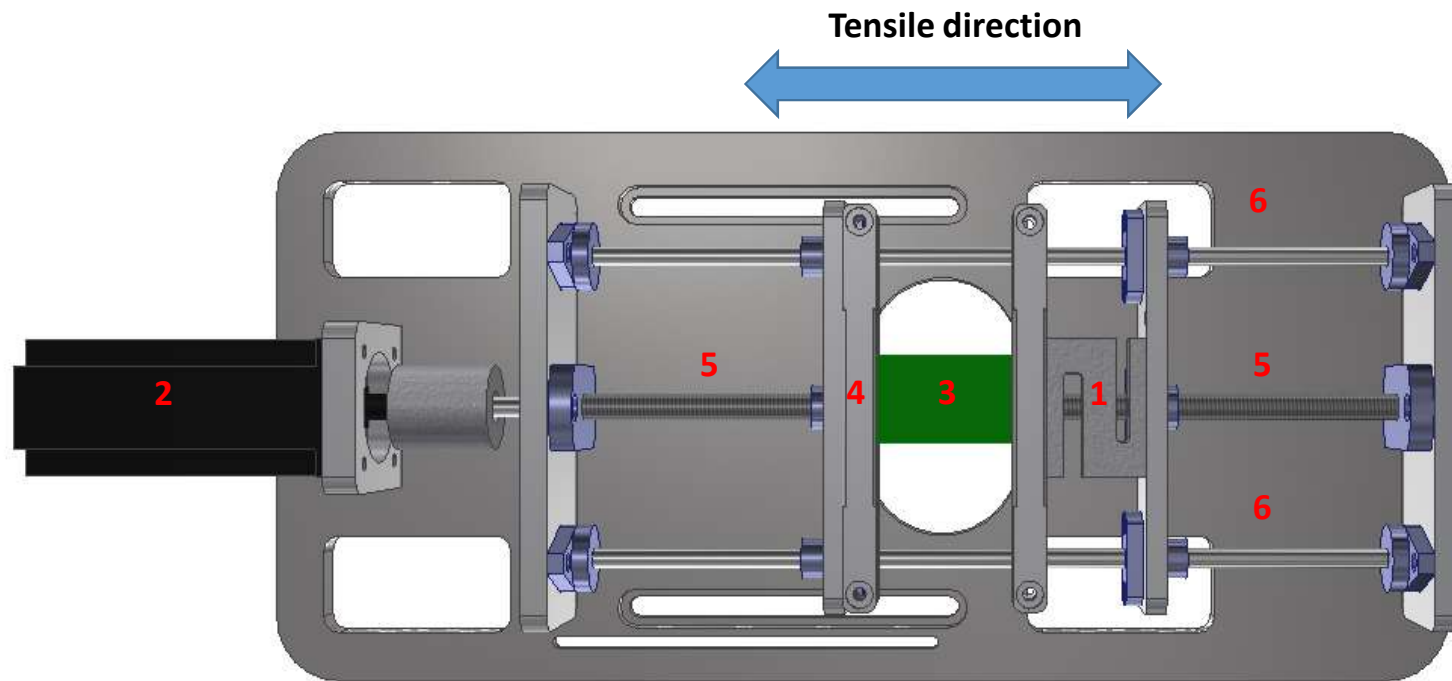
constant detection position

DWS spatial resolution limitation



big enough sample size

Fabrication of bidirectional tensile stage



- 1. Force Sensor
- 2. Motor
- 3. Sample
- 4. Clamps
- 5. Bidirectional ball screw
- 6. Slides shaft

Chosen sample size: 2mm x 20mm x 50mm

Calculated Strength range: 0-12.5 MPa

Moving distance: 0~150 mm

Sample width: 0~100 mm

Application of DWS technology on polymer network

- **1. Sample preparation**

Introduction probe particles during crosslinking

- 1. PDMS (model sample)
- 2. Multiple networks from acrylates (from Labortory) ← We are here
- 3. Double Dynamic networks (from other partners)

- **2. Set-up development**

- 1. optical part (DWS testing system)
 - 2. mechanical part (Tensile machine) }
- On the way

Thank you!